

**Form PTO-1449 Modified**

List of Patent and Publications  
Cited by Applicant  
(Use several sheets if necessary)

U.S. Department of Commerce  
Patent and Trademark Office

Docket No.  
**THOM-0012**

Serial No.  
**09/646,032**

Applicant  
**W.P. Thompson & Company**

Filing Date  
**September 13, 2000**

Group  
**Not Assigned Yet**

**U. S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Date	Name	Class	Subclass

**FOREIGN PATENT DOCUMENTS**

Examiner Initial		Document No.	Date	Country	Translation YES NO	
J.Y.	AA	EPO 399 299 A	11/28/90	EPO	X	
J.Y.	AB	GB 2 233 334 A	1/9/91	GB	X	
J.Y.	AC	WO 95 28742 A	10/26/95	WORLD	X	
J.Y.	AD	EPO 540 839 A	5/12/93	EPO	X	

**EXAMINER***Jessie L. Jan***DATE CONSIDERED** 2-13-03



Sheet 2 of 2

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		Applicant <b>W.P. Thompson &amp; Company</b>	
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<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>			
J.Y.	AE	Asano, T., et al., "Field Emission From Ion Irradiated Photoresist", <i>Japanese Journal of Applied Physics</i> , <b>1997</b> , Vol. 36, NR. 6B, L818-L820	
J.Y.	AF	Musa, I., et al., "Ultra-Low-Threshold Field Emission From Conjugated Polymers", <i>Nature</i> , <b>1998</b> , Vol. 395, 362-365	
J.Y.	AG	Musa, I., et al., "Analysis of Low Threshold Field-Emission From Conjugated Polymers for Displays", <i>International Electron Devices Meeting, Technical Digest</i> , <b>1998</b> , 867-869	
J.Y.	AH	Takahashi Toshihiko, Applicant: Richo Co. Ltd., "Patent Abstracts of Japan", <i>Publication No. 03216998</i> , <b>24-09-91</b> ; <i>Application No. 02009785</i> , <b>19-01-90</b>	
EXAMINER <i>Juie Zhan</i>		DATE CONSIDERED <i>2-13-03</i>	